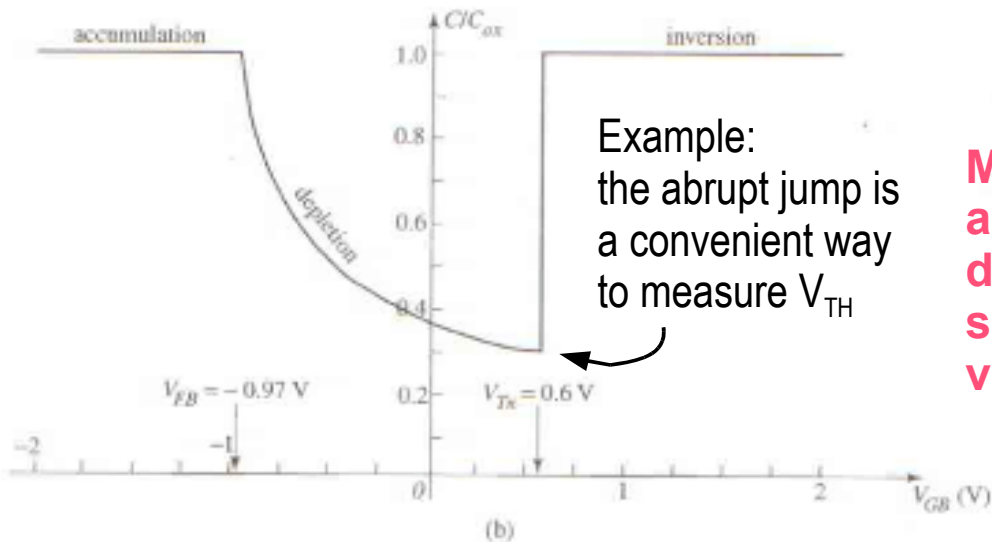
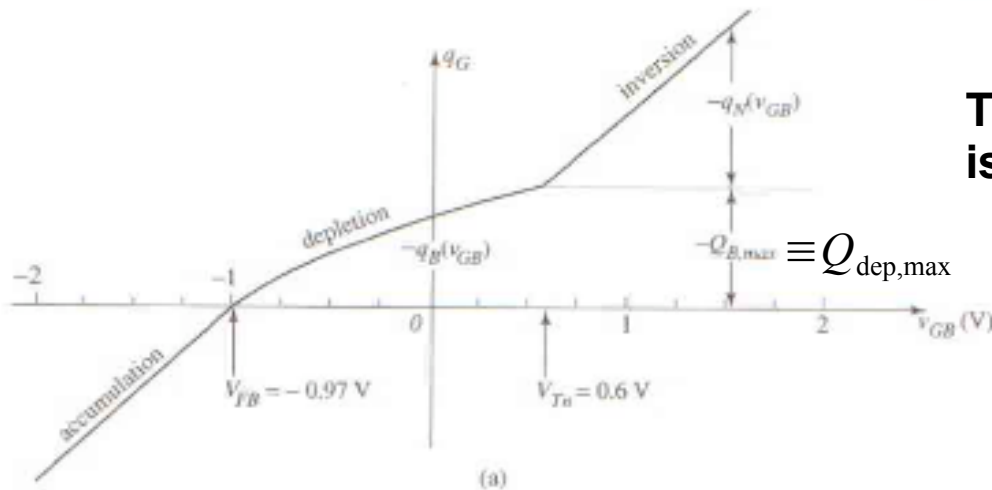


# Capacitance of the MOS structure

The capacitance we refer in MOS theory is always the small signal capacitance:

$$C(V_{GB}) = \frac{dQ_g}{dV_{gb}} \Big|_{V_{GB}} \equiv \frac{dq_G}{dv_{GB}} \Big|_{V_{GB}}$$



**MOS C-V Characteristic measurements are a commonly used method of determining gate oxide thickness, substrate doping concentration, flat-band voltage and threshold voltage**

► **Figure 3.35** (a) Gate charge as a function of gate-bulk voltage for an MOS capacitor on a p-type substrate with a 150 Å-thick gate oxide and a substrate doping  $N_a = 10^{17}$  cm<sup>-3</sup> and (b) capacitance as a function of gate-bulk voltage, found by graphically differentiating (a).

# MOS C-V behavior

- Accumulation

$$C = C_{ox}$$

- Depletion

$$C = \frac{C_{ox} C_{dep}}{C_{ox} + C_{dep}} \quad \text{series of } C_{ox} \text{ and } C_{dep}$$

- Inversion

$$C = C_{ox}$$

# Mathematical Derivation

- Accumulation:  $v_{GB} \leq V_{FB}$

$$\mathbb{C} = \frac{d[\mathbb{C}_{ox}(v_{GB} - V_{FB})]}{dv_{GB}} \Big|_{V_{GB}} = \mathbb{C}_{ox}$$

- Inversion:  $v_{GB} > V_{TH}$

$$\mathbb{C} = \frac{d[\mathbb{C}_{ox}(v_{GB} - V_{TH}) - \mathbb{Q}_{\text{dep,max}}]}{dv_{GB}} \Big|_{V_{GB}} = \mathbb{C}_{ox}$$

# Mathematical Derivation

- Depletion:  $V_{FB} < v_{GB} \leq V_{TH}$

$$C = \frac{d[-Q_{dep}]}{dv_{GB}} \Big|_{V_{GB}} =$$

$$-Q_{dep} = q N_A X_d$$

$$X_d = \frac{\epsilon_s}{C_{ox}} \left( \sqrt{1 + \frac{2C_{ox}^2 (v_{GB} - V_{FB})}{q N_A \epsilon_s}} - 1 \right)$$

$$= \frac{d}{dv_{GB}} \left[ \frac{q N_A \epsilon_s}{C_{ox}} \left( \sqrt{1 + \frac{2C_{ox}^2 (v_{GB} - V_{FB})}{q N_A \epsilon_s}} - 1 \right) \right]_{V_{GB}} =$$

$$= \frac{d}{dv_{GB}} \left[ \frac{q N_A \epsilon_s}{C_{ox}} \sqrt{1 + \frac{2C_{ox}^2 (v_{GB} - V_{FB})}{q N_A \epsilon_s}} - \frac{q N_A \epsilon_s}{C_{ox}} \right]_{V_{GB}} =$$

$$= \frac{q N_A \epsilon_s}{C_{ox}} \frac{d}{dv_{GB}} \left[ \left( \sqrt{1 + \frac{2C_{ox}^2 (v_{GB} - V_{FB})}{q N_A \epsilon_s}} \right) \right]_{V_{GB}} = \longrightarrow$$

# Mathematical Derivation

$$= \frac{q N_A \epsilon_s}{C_{ox}} \frac{d}{dv_{GB}} \left[ \left( 1 + \frac{2 C_{ox}^2 (v_{GB} - V_{FB})}{q N_A \epsilon_s} \right)^{1/2} \right]_{V_{GB}} =$$

$$= \frac{\cancel{q N_A \epsilon_s}}{\cancel{C_{ox}}} \left[ \frac{1}{\cancel{2}} \left( 1 + \frac{2 C_{ox}^2 (v_{GB} - V_{FB})}{q N_A \epsilon_s} \right)^{-1/2} \left( \frac{\cancel{2 C_{ox}^2}}{\cancel{q N_A \epsilon_s}} \right) \right]_{V_{GB}} =$$

$= \frac{C_{ox}}{\sqrt{1 + \frac{2 C_{ox}^2 (V_{GB} - V_{FB})}{q N_A \epsilon_s}}}$	<p><b>Capacitance in Depletion</b></p> $V_{FB} < v_{GB} \leq V_{TH}$
---	--

- In order to better understand the “nature” of the capacitance we just found let's try to express it in term of the depletion layer width

# Mathematical Derivation

$$X_d = \frac{\epsilon_s}{\mathbf{C}_{ox}} \left( \sqrt{1 + \frac{2\mathbf{C}_{ox}^2 (V_{GB} - V_{FB})}{q N_A \epsilon_s}} - 1 \right) =$$

$$= \frac{\epsilon_s}{\mathbf{C}_{ox}} \sqrt{1 + \frac{2\mathbf{C}_{ox}^2 (V_{GB} - V_{FB})}{q N_A \epsilon_s}} - \frac{\epsilon_s}{\mathbf{C}_{ox}}$$



$$X_d + \frac{\epsilon_s}{\mathbf{C}_{ox}} = \frac{\epsilon_s}{\mathbf{C}_{ox}} \sqrt{1 + \frac{2\mathbf{C}_{ox}^2 (V_{GB} - V_{FB})}{q N_A \epsilon_s}}$$



$$\frac{1}{\sqrt{1 + \frac{2\mathbf{C}_{ox}^2 (V_{GB} - V_{FB})}{q N_A \epsilon_s}}} = \frac{\epsilon_s / \mathbf{C}_{ox}}{X_d + \epsilon_s / \mathbf{C}_{ox}}$$

# Mathematical Derivation

$$\frac{1}{\sqrt{1 + \frac{2C_{ox}^2(V_{GB} - V_{FB})}{qN_A\epsilon_s}}} = \frac{\epsilon_s/C_{ox}}{X_d + \epsilon_s/C_{ox}}$$

$$C = \frac{C_{ox}}{\sqrt{1 + \frac{2C_{ox}^2(V_{GB} - V_{FB})}{qN_A\epsilon_s}}} = \frac{\epsilon_s}{X_d + \epsilon_s/C_{ox}} = \frac{1}{\frac{X_d}{\epsilon_s} + \frac{1}{C_{ox}}}$$

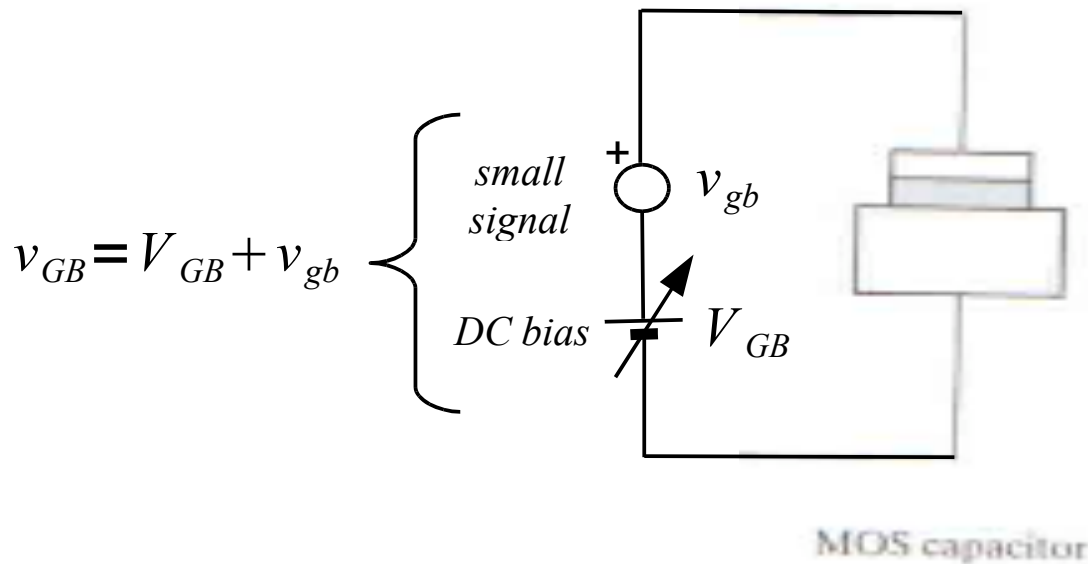
**NOTE:**  $\epsilon_s/X_d$  is simply the capacitance per area of the depletion region

$$C = \frac{1}{\frac{1}{\frac{\epsilon_s}{X_d}} + \frac{1}{C_{ox}}} = \frac{1}{\frac{1}{C_{dep}} + \frac{1}{C_{ox}}} = \frac{C_{ox} \cdot C_{dep}}{C_{ox} + C_{dep}}$$

Series of  $C_{ox}$  and  $C_{dep}$

# Physical Interpretation

- We investigate where the increment in gate charge  $q_g$  due to a positive increment in the gate voltage  $v_{gb}$  (relative to the DC gate voltage  $V_{GB}$  and charge  $Q_G$ ) is mirrored for each of the three operating regions

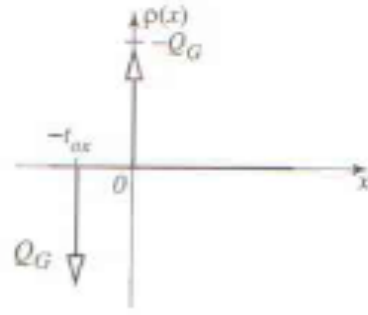




# Accumulation

$$V_{GB} < V_{FB} < 0$$

$$Q_G < 0$$



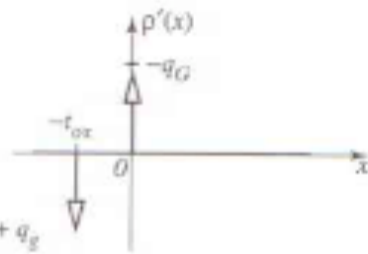
(a)

$$v_{GB} = V_{GB} + v_{gb}$$

$$(v_{gb} > 0)$$

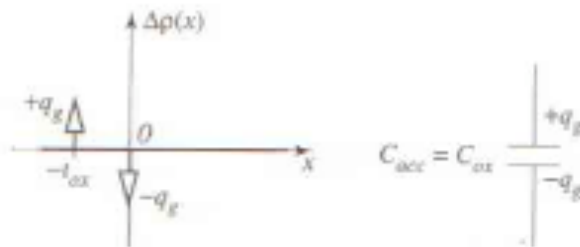
$$q_G = Q_G + q_g$$

$$> Q_G$$



(b)

$$q_g = q_G - Q_G$$

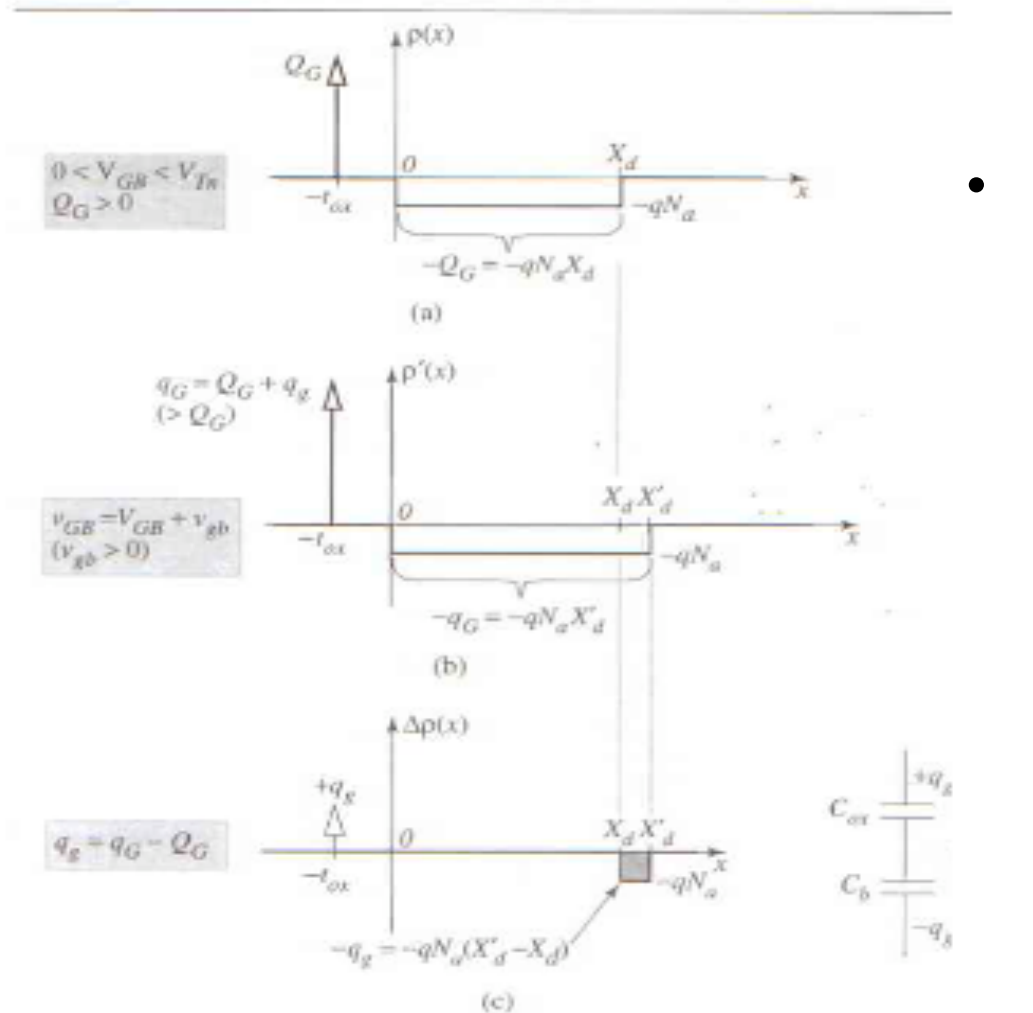


(c)

- The charge increment on the gate is mirrored in the accumulated holes under the oxide/substrate interface

► **Figure 3.37** Charge density  $\rho(x)$  for a MOS structure on a p-type substrate in accumulation: (a) bias voltage  $V_{GB} < V_{FB}$ , (b) perturbed charge density  $\rho'(x)$  for  $v_{GB} = V_{GB} + v_{gb}$ , where the incremental voltage  $v_{gb} > 0$ , and (c) incremental charge density  $\Delta\rho(x) = \rho'(x) - \rho(x)$  showing that the incremental charges  $\pm q_g$  are separated by the gate oxide. The small-signal model in accumulation is the oxide capacitance.

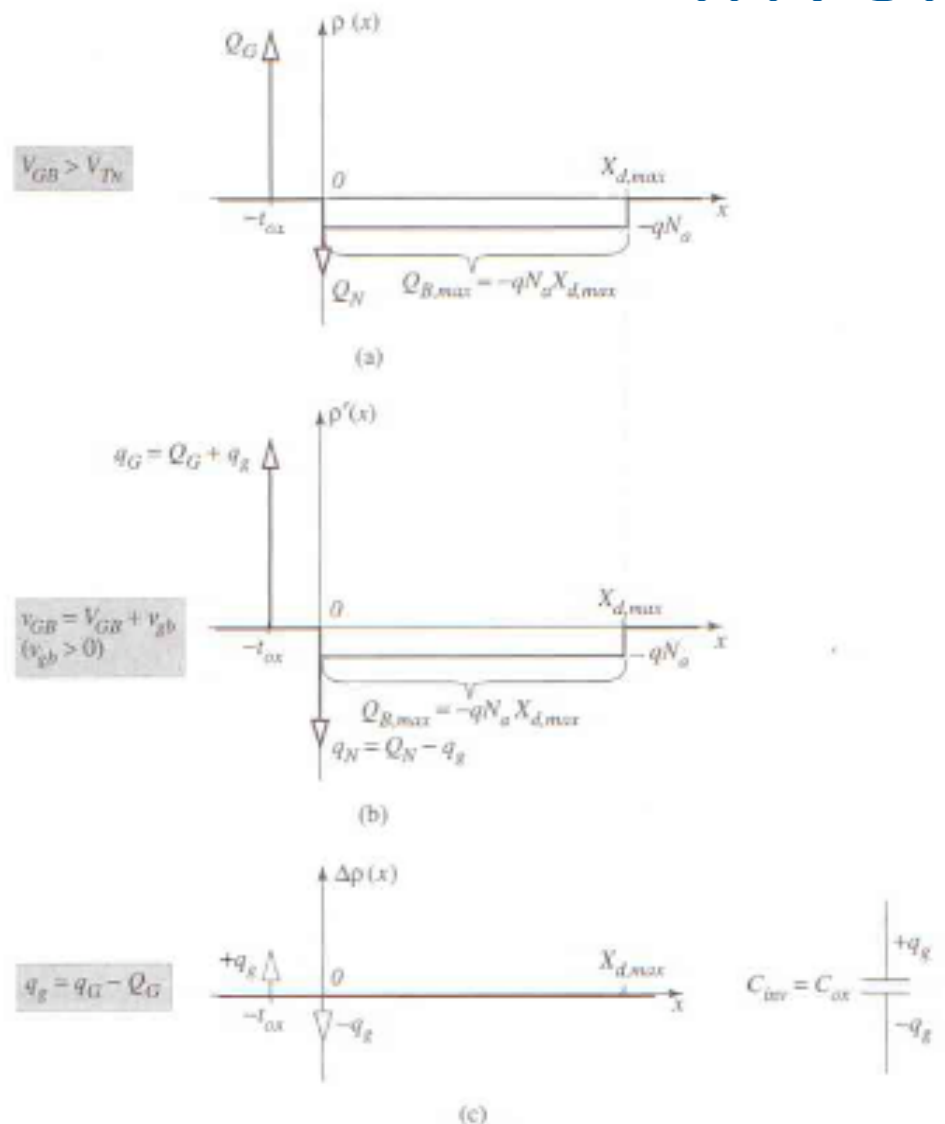
# Depletion



- The gate charge increment is mirrored at the bottom of the depletion region. The incremental charges  $+q_g$  and  $-q_g$  are separated by an oxide layer of thickness  $t_{ox}$  with capacitance  $C_{ox} = \epsilon_s/t_{ox}$  and a depletion region of thickness  $X_d(V_{GB})$  with capacitance  $\epsilon_s/X_d(V_{GB})$ .

► **Figure 3.38** Charge density  $\rho(x)$  for a MOS structure on a p-type substrate in depletion: (a) bias voltage  $V_{FB} < V_{GB} < V_{Tn}$ , (b) perturbed charge density  $\rho'(x)$  for  $v_{GB} = V_{GB} + v_{gb}$ , where the incremental voltage  $v_{gb} > 0$ , and (c) incremental charge density  $\Delta\rho(x) = \rho'(x) - \rho(x)$  showing that the incremental charges  $\pm q_g$  are separated by the gate oxide and the depletion region. The small-signal model in depletion is two capacitors in series.

# Inversion

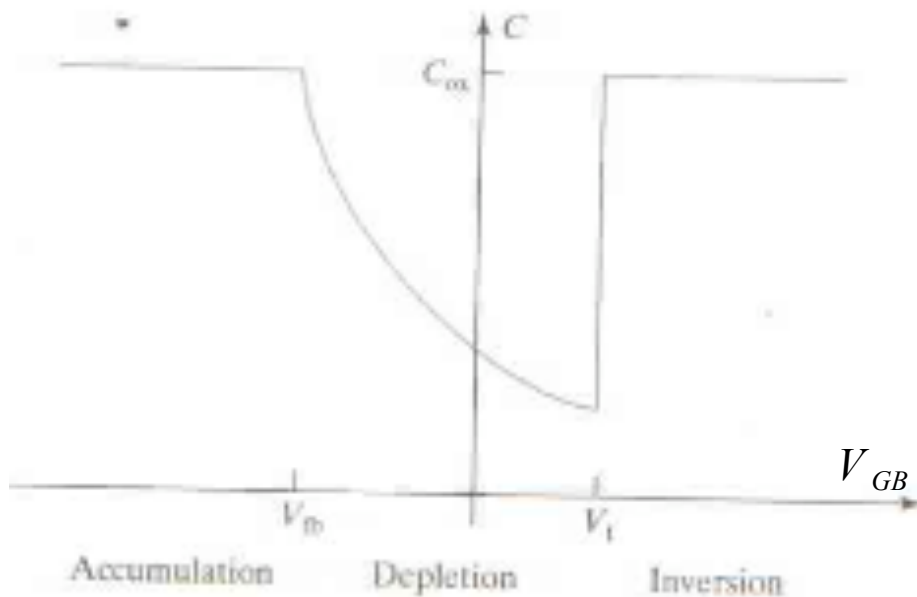


For an inverted MOS capacitor, an increment in gate voltage is mirrored in an increase electron charge in the inversion layer

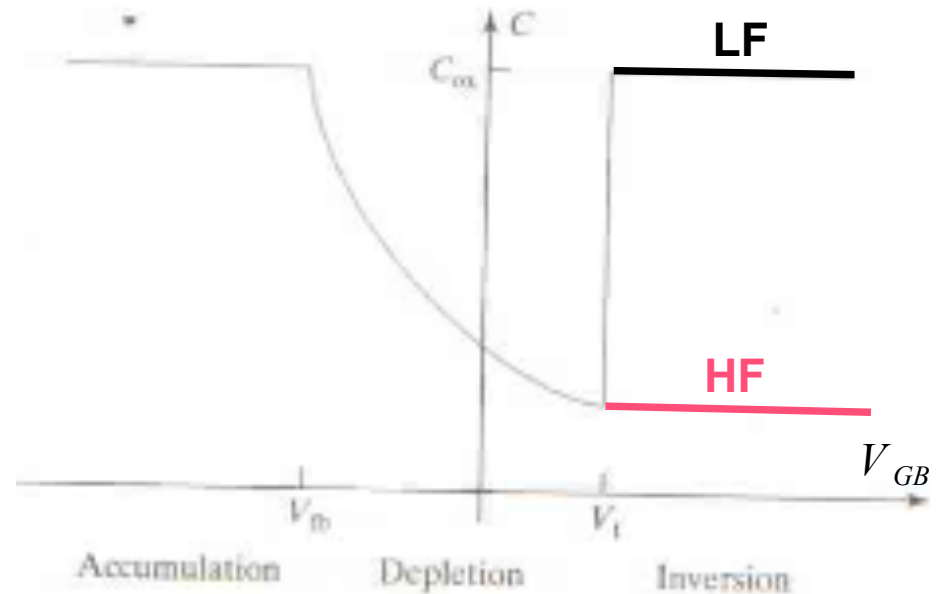
► **Figure 3.39** Charge density  $\rho(x)$  for a MOS capacitor on a p-type substrate in inversion: (a) bias voltage  $V_{GB} > V_{TN}$ , (b) perturbed charge density  $\rho'(x)$  for  $V_{GB} = V_{GB} + v_{gb}$ , where the incremental voltage  $v_{gb} > 0$ , and (c) incremental charge density  $\Delta\rho(x) = \rho'(x) - \rho(x)$  showing that the incremental gate charge is mirrored by an increment in the electron inversion charge. Therefore, the small-signal model in the inversion region is again the oxide capacitance.

# MOS C-V behavior with frequency

- **LF**



- **HF**



- If the signal is too fast the device cannot keep up forming the inversion layer